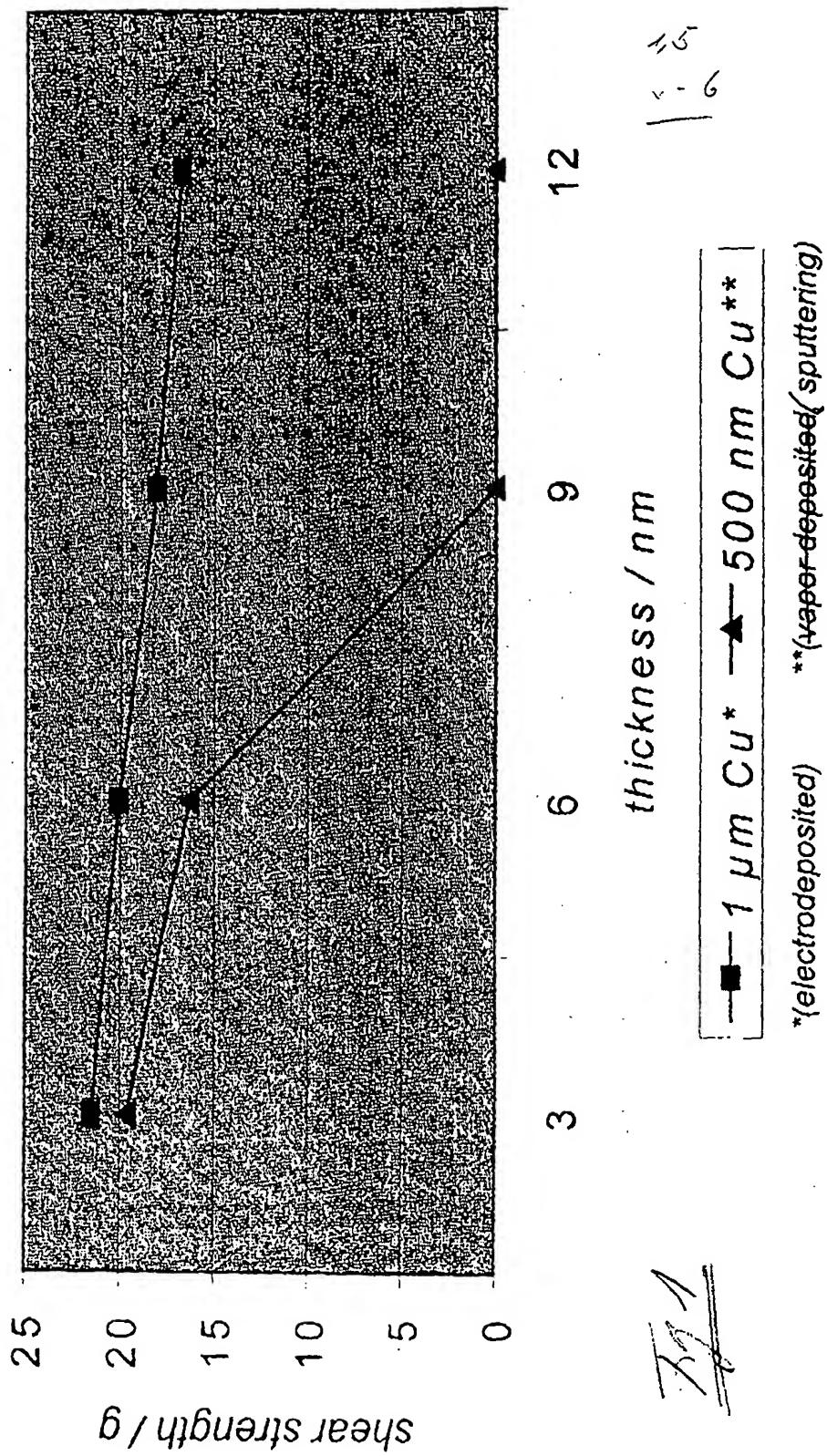


Shear strength in function of SiO_2 layer thickness for
wire bonding at 200°C (Figure 1)



09/349,014

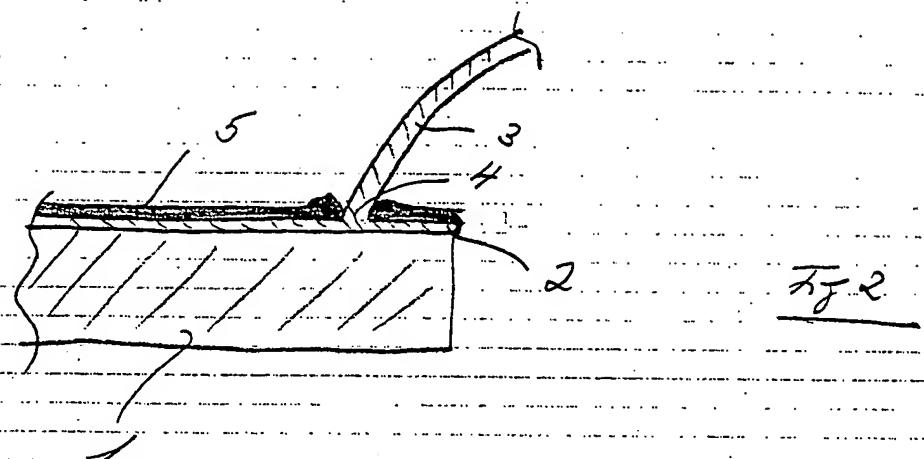


Fig. 3

